



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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### LABORATORY GROWN DIAMOND REPORT

January 30, 2026

IGI

Report Number

LG770605416

Description LABORATORY GROWN DIAMOND

Shape and Cutting Style ROUND BRILLIANT

Measurements 10.28 - 10.31 X 6.32 MM

#### GRADING RESULTS

Carat Weight 4.10 CARATS

Color Grade E

Clarity Grade VS 1

Cut Grade IDEAL

#### ADDITIONAL GRADING INFORMATION

Polish EXCELLENT

Symmetry EXCELLENT

Fluorescence NONE

Inscription(s) IGI LG770605416

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila

LG770605416  
Report verification at [igi.org](http://igi.org)

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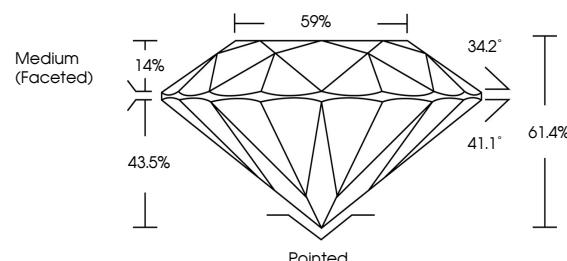
E

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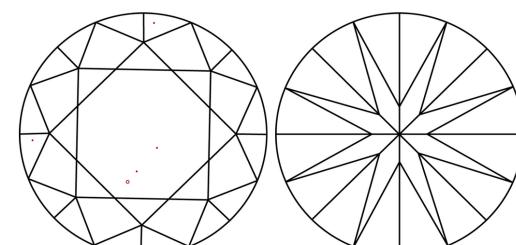
Clarity Grade Cut Grade

#### PROPORTIONS



Sample Image Used

#### CLARITY CHARACTERISTICS



#### KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

#### COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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#### CLARITY

FL	IF	VS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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